

033082M309

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Masahiro SHIMIZU, et al.

**CONFIRMATION NO.: 5342**

U.S. Serial No.: 10/573,048

Group Art Unit: TBA

Filed: March 22, 2006

Examiner: TBA

For: THERMAL PROCESSING APPARATUS

**THIRD INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) which lists a Japanese Office Action issued on September 15, 2009 being submitted herewith. A copy of JP62-015816A cited therein is enclosed. No copy of document JP2002-299319A listed in the Office Action is enclosed because it was cited previously in Applicants' (first) IDS filed with this application.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application. This Information Disclosure Statement is being filed in advance of the receipt of a first Office Action in this application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,  
SMITH, GAMBRELL & RUSSELL, LLP

By: 

Michael A. Makuch, Reg. No. 32,263  
1130 Connecticut Avenue, Suite 1130  
Washington, D.C. 20036  
Telephone: (202) 263-4300  
Fax: (202) 263-4329

November 24, 2009